

Docket No.: HSI-0001



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Confirmation No.: 1151

Ki Beom KIM et al.

Group Art Unit: 1763

Serial No.: 10/621,471

Examiner: Richard R. BUEKER

Filed: 7/18/2003

Customer No.: 34610

For: SOURCE FOR THERMAL PHYSICAL VAPOR DEPOSITION OF ORGANIC  
ELECTROLUMINESCENT LAYERS

**REQUEST FOR CORRECTION OF INVENTORSHIP**  
**UNDER 37 C.F.R. §1.48(b)**

U.S. Patent and Trademark Office  
Customer Service Window  
Randolph Building  
401 Dulany Street  
Alexandria, Virginia 22314

Sir:

Consistent with the provisions of 37 C.F.R. §1.48(b), Applicants respectfully request Correction of the Inventorship of the above-identified application to **delete** Ki Beom Kim and Seok Joo Kim as named inventors. The prosecution of the present application has resulted in cancellation of claims so that fewer than all of the currently named inventors are the actual inventors of the invention currently being claimed.

Upon grant of this Request, the inventors of the present application are:

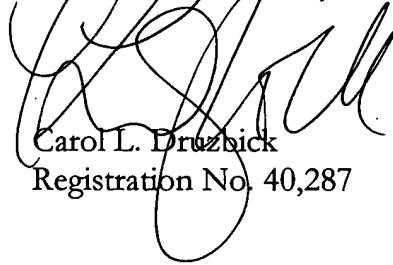
1. Sang Dae KIM;
2. Yoon Soo HAN; and
3. Yoon Heun TAK.

10/28/2005 JADD01 00000005 10621471 130.00 0P  
01 FC:1464

Grant of the foregoing Request is respectfully solicited.

Attached herewith is Check No. 16039 for \$130.00 in payment of the fee set forth under 37 C.F.R. §1.117(i). Please charge any other fees which may be required or credit any overpayment to Deposit Account No. 16-0607.

Respectfully submitted,  
FLESHNER & KIM, LLP



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**Date:**

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